



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 8585  
Takashi OHSAKO et al. : Attorney Docket No. 2003\_1364A  
Serial No. 10/677,221 : Group Art Unit 2823  
Filed October 3, 2003 : Examiner Joannie Garcia  
METHOD OF MANUFACTURING : Mail Stop: AF  
SEMICONDUCTOR ELEMENT

AMENDMENT AFTER FINAL

Please

Enter Commissioner for Patents  
/J.G./ P.O. Box 1450  
02/05/2008 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated October 30, 2007, please amend the above-identified application as follows.

RESPONSE UNDER 37.CFR1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2823

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975